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CONFIRMATION NO. 7682

SERIAL NUMBER	FILING or 371(c) DATE	CLASS	GROUP ART UNIT	ATTORNEY DOCKET NO.		
10/567,729	02/01/2006	257	2814	OGOSH46USA		
RULE						
APPLICANTS Kazutoshi Kojima, Ibaraki, JAPAN; Satoshi Kuroda, Ibaraki, JAPAN; Hajime Okumura, Ibaraki, JAPAN; ** CONTINUING DATA ***** This application is a 371 of PCT/JP04/11894 08/19/2004 ** FOREIGN APPLICATIONS ***** JAPAN 2003-295413 08/19/2003 ** IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 08/23/2006						
Foreign Priority claimed <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No	35 USC 119(a-d) conditions met <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No	<input type="checkbox"/> Met after Allowance	STATE OR COUNTRY	SHEETS DRAWINGS	TOTAL CLAIMS	INDEPENDENT CLAIMS
Verified and /SARAH KATE SALERNO/ Acknowledged Examiner's Signature		Initials	JAPAN	3	20	3
ADDRESS HOWSON AND HOWSON SUITE 210 501 OFFICE CENTER DRIVE FT WASHINGTON, PA 19034 UNITED STATES						
TITLE Silicon carbide epitaxial wafer, method for producing such wafer, and semiconductor device formed on such wafer						
FILING FEE RECEIVED 900	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:			<input type="checkbox"/> All Fees		
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